

Weekly Report 8

March 4th 2013 to March 11th 2013

General Information

Group Number: 13-25

Group Advisor: Professor Gary Tuttle

Client: Professor Gary Tuttle

Accomplishments

- Continued mask testing. (will take several weeks)
- The NMOS source/drain lithography was done this week.

Plan for Coming Week

- Continue lithography mask testing at MRC

Pending Issues

Individual Contributions

Daniel O'Connell - 2 hours

Levi Weiss - 2 hours

Benjamin Ch'ng - 2 hours

Chen Wen - 2 hours

Liao Wang - 2 hours